

SEP 20 2007  
TROP, PRUNER & HU, P.C.  
INTELLECTUAL PROPERTY LAW ATTORNEYS1616 South Voss Road, Suite 750  
Houston, Texas 77057-2631  
Bus: (713) 468-8880  
Fax: (713) 468-8883

# Fax

<b>To:</b>	Examiner Long Pham	<b>From:</b>	Timothy N. Trop
<b>Company:</b>	US Patent Office	<b>Date:</b>	September 20, 2007
<b>Fax:</b>	(571) 273-8300	<b>Pages:</b>	8 (including cover sheet)
<b>Your Re:</b>	10/822,361	<b>Our Re:</b>	ITL0835D1US

☐ Urgent    ☐ For Review    ☐ Please Comment    ☐ Please Reply    ☐ Confirm Receipt

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CENTRAL FAX CENTER****SEP 20 2007****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Applicant:	Ilya Karpov et al.	§	Art Unit:	2814
Serial No.:	10/822,361	§	Examiner:	Long Pham
Filed:	April 12, 2004	§	Docket:	ITL.0835D1US P14730D
For:	Fabricating Deeper and Shallower Trenches in Semiconductor Structures	§	Assignee:	Intel Corporation
		§	Conf. No.	3077

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REPLY TO FINAL REJECTION**

Sir:

In response to the final rejection mailed August 15, 2007, please amend the above-referenced patent application as follows:

Date of Deposit: September 20, 2007  
I hereby certify that this document is being facsimile transmitted to the  
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date indicated above.  
*Cynthia L. Hayden*  
Cynthia L. Hayden